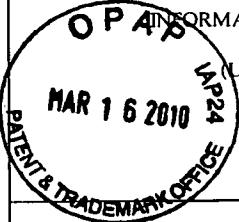


Form PTO-1449 (REV. 1/06)		US Dept. of Commerce PATENT & TRADEMARK OFFICE	ATTY DOCKET NO. 129429	APPLICATION NO. 10/593,802
O P A S INFORMATION DISCLOSURE STATEMENT Use several sheets if necessary 			APPLICANT(S) Hideaki HARA	
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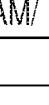
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